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	APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
	09/478,812	01/07/2000	Yukiyasu Sugano	SON-1718	2204
	7590 08/28/2006 Ronald P Kananen Esq			EXAMINER	
				LEE, EUGENE	
	Rader Fishman & Grauer			ART UNIT	PAPER NUMBER
		The Lion Building 1233 20th Street NW Suite 501 Washington, DC 20036			TATER NOMBER
					2815 DATE MAILED: 08/28/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)						
	09/478,812	SUGANO ET AL.						
Office Action Summary	Examiner	Art Unit						
	Eugene Lee	2815						
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address						
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	TE OF THIS COMMUNICATION 6(a). In no event, however, may a reply be timil apply and will expire SIX (6) MONTHS from cause the application to become ABANDONEI	the mailing date of this communication. D (35 U.S.C. § 133).						
Status								
1)⊠ Responsive to communication(s) filed on <u>15 Ju</u>	ne 2006.							
	action is non-final.							
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
					Disposition of Claims			
4) Claim(s) 11,12,17,18,27,28,39,40,53,54,63,65,	☑ Claim(s) <u>11,12,17,18,27,28,39,40,53,54,63,65,73 and 74</u> is/are pending in the application.							
4a) Of the above claim(s) is/are withdrawn from consideration.								
5) Claim(s) is/are allowed.								
6)⊠ Claim(s) <u>11,12,17,18,27,28,39,40,53,54,63,65,73 and 74</u> is/are rejected. 7)□ Claim(s) is/are objected to.								
					8) Claim(s) are subject to restriction and/or	election requirement.		
Application Papers								
9)☐ The specification is objected to by the Examiner.								
I0) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.								
Applicant may not request that any objection to the o	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
Priority under 35 U.S.C. § 119								
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).								
a)⊠ All b)□ Some * c)□ None of:								
 Certified copies of the priority documents have been received. Certified copies of the priority documents have been received in Application No Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). 								
						* See the attached detailed Office action for a list	* * * * * * * * * * * * * * * * * * * *	ed.
						and allaurica actailed office action for a list of the certified copies not received.		
Attachment(s)								
1) Notice of References Cited (PTO-892)	4) Interview Summary							
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) 	Paper No(s)/Mail Da 5) Notice of Informal P	ate Patent Application (PTO-152)						
Paper No(s)/Mail Date	6) Other:	· · · · · · · · · · · · · · · · · · ·						

Application/Control Number: 09/478,812 Page 2

Art Unit: 2815

DETAILED ACTION

Claim Objections

1. Claim 11 is objected to because of the following informalities: the word "wherein" is repeated twice in the last paragraph of the claim. Appropriate correction is required.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claims 11, 27, 39, 53, 63, and 73 are rejected under 35 U.S.C. 102(b) as being rejected by Noguchi et al. 5,529,951. Noguchi discloses (see, for example, FIG. 23A-23E) a MOS transistor (thin film semiconductor device) 260 comprising a polycrystalline silicon thin film (semiconductor thin film) 241a, gate insulating film 243, and gate electrode 246. In column 22, lines 46-47, Noguchi discloses the silicon thin film having a thickness of 40 nm (30-80 nm). In column 22, lines 48-54, Noguchi discloses the excimer laser light being irradiated on the amorphous silicon layer which recrystallizes the layer to a polycrystalline thin film. This excimer laser light is a single shot radiation that avoids the poor uniformity that is found in the polycrystalline films that have irradiation in several pulses (see, for example, column 2, lines 51-64 of Noguchi). In FIG. 21, Noguchi discloses an excimer laser light (single shot irradiation) 215 that forms a borderless (uniform) silicon thin film.

Application/Control Number: 09/478,812 Page 3

Art Unit: 2815

The limitation "wherein said semiconductor thin film is accumulated without exposing said substrate to the air" is a product-by-process limitation of producing a thin film with greater thickness.

Regarding claims 39, the limitation "irradiated with pulse laser light having an emission time width from upstand to downfall of at least 50 ns" is a product-by-process limitation of converting the semiconductor thin film into polycrystalline silicon.

Regarding claim 73, the limitation "substrate is cooled to a temperature lower than room temperature" is a product-by-process limitation of converting the semiconductor thin film into polycrystalline silicon.

Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claims 12, 28, 40, 54, 65, and 74 stand rejected under 35 U.S.C. 103(a) as being unpatentable over Noguchi et al. '951 as applied to claims 11, 27, 39, 53, 63, and 73 above, and further in view of Tanaka et al. 5,798,744. Noguchi does not disclose a display device comprising a pair of substrates adhered to each other with a prescribed gap, and an electrooptical substance maintained in said gap, one of said substrate comprises a counter electrode, the other substrate comprises a pixel electrode and a thin film transistor driving said pixel electrode.

Art Unit: 2815

However, Tanaka discloses (see, for example, FIG. 3) a liquid crystal display apparatus comprising pair of substrates 12/10, liquid crystal (electrooptical substance) 200, counter electrodes 170r, and pixel electrode 150. These components are used to form liquid pixels in a LCD display apparatus. Therefore, it would have been obvious to one of ordinary skill in the art at time of invention to have a display device comprising a pair of substrates adhered to each other with a prescribed gap, and an electrooptical substance maintained in said gap, one of said substrate comprises a counter electrode, the other substrate comprises a pixel electrode and a thin film transistor driving said pixel electrode in order to form the thin film semiconductor device in a LCD display apparatus.

Regarding claim 28, the limitation "said semiconductor thin film is accumulated by alternately repeating said film forming step, where each additional formed film is about 1 nm" produces a semiconductor thin film of greater thickness. Increasing the thickness of a thin film increases its current carrying capacity. Therefore, it would have been obvious to one having ordinary skill in the art at the time of the invention was made to form a layer of about 30 to 80 nm and accumulate the semiconductor thin films in order to produce a thin film with greater current carrying capacity.

6. Claim 17 stand rejected under 35 U.S.C. 103(a) as being unpatentable over Noguchi et al. 5,529,951 in view of Yamazaki et al. 6,037,197. Noguchi discloses (see, for example, FIG. 23A-23E) a MOS transistor (thin film semiconductor device) 260 comprising a polycrystalline silicon thin film (semiconductor thin film) 241a, gate insulating film 243, and gate electrode 246. In column 22, lines 46-47, Noguchi discloses the silicon thin film 241 having a thickness of 40 nm

Application/Control Number: 09/478,812

Art Unit: 2815

(30-80 nm). In column 22, lines 48-54, Noguchi discloses the excimer laser light being irradiated on the amorphous silicon layer which recrystallizes the layer to a polycrystalline thin film. This excimer laser light is a single shot radiation that avoids the poor uniformity that is found in the polycrystalline films that have irradiation in several pulses (see, for example, column 2, lines 51-64 of Noguchi). In FIG. 21, Noguchi discloses an excimer laser light (single shot irradiation) 215 that forms a borderless (uniform) silicon thin film. Noguchi does not disclose said at least one unit. However, Yamazaki discloses (see, for example, FIG. 1C) a pixel matrix circuit comprising three TFTs (said units). In column 5, lines 43-45, Yamazaki discloses that pixel matrix circuits have more than one million TFTs. Therefore, it would have been obvious to one of ordinary skill in the art at the time of invention to have said at least one unit in order to form the thin film semiconductor device in a pixel matrix circuit of an LCD device.

7. Claim 18 is rejected under 35 U.S.C. 103(a) as being unpatentable over Noguchi et al. '951 in view of Tanaka et al. '744 as applied to claims 12, 28, 40, 54, 65, and 74 above, and further in view of Yamazaki et al. 6,037,197. Noguchi in view of Tanaka does not disclose said at least one unit. However, Yamazaki discloses (see, for example, FIG. 1C) a pixel matrix circuit comprising three TFTs (said units). In column 5, lines 43-45, Yamazaki discloses that pixel matrix circuits have more than one million TFTs. Therefore, it would have been obvious to one of ordinary skill in the art at the time of invention to have at least one unit in order to form the thin film semiconductor device in a pixel matrix circuit of an LCD device.

Application/Control Number: 09/478,812 Page 6

Art Unit: 2815

Response to Arguments

8. Applicant's arguments filed 6/15/06 have been fully considered but they are not persuasive.

Product-by-Process Limitations

While not objectionable, the Office reminds Applicant that "product by process" limitations in claims drawn to structure are directed to the product, per se, no matter how actually made. *In re Hirao*, 190 USPQ 15 at 17 (footnote 3). See also, *In re Brown*, 173 USPQ 685; *In re Luck*, 177 USPQ 523; *In re Fessmann*, 180 USPQ 324; *In re Avery*, 186 USPQ 161; *In re Wethheim*, 191 USPQ 90 (209 USPQ 554 does not deal with this issue); *In re Marosi et al.*, 218 USPQ 289; and particularly *In re Thorpe*, 227 USPQ 964, all of which make it clear that it is the patentability of the final product per se which must be determined in a "product by process" claim, and not the patentability of the process, and that an old or obvious product produced by a new method is not patentable as a product, whether claimed in "product by process" claims or *otherwise*. Note that applicant has the burden of proof in such cases, as the above case law makes clear. Thus, no patentable weight will be given to those process steps, which do not add structural limitations to the final product.

In this case, the limitation "wherein said semiconductor thin film is accumulated without exposing said substrate to air to accumulate said semiconductor thin film" is a product-by-process limitation of making a thin film of greater thickness. Therefore, such a process, as stated in the applicant's claims, does not structurally differentiate the thin film of Noguchi from the thin film in the applicant's claims.

The applicant's arguments on pages 8, 9, 14, and 15 of the amendment filed 6/15/06 that Noguchi does not disclose various limitations, this argument is not persuasive. The limitations cited by the applicant are product-by-process limitations of forming a polycrystalline thin film structure. Since the claims are directed towards product and Noguchi discloses a polycrystalline thin film, the applicant's claims do not structurally differentiate from the structure disclosed by Noguchi.

Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Application/Control Number: 09/478,812

Art Unit: 2815

INFORMATION ON HOW TO CONTACT THE USPTO

Page 8

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Eugene Lee whose telephone number is 571-272-1733. The examiner can normally be reached on M-F 8-5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kenneth Parker can be reached on 571-272-2298. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Eugene Lee August 21, 2006

EUGENE LEE PRIMARY EXAMINER

90